

EAST Search History

EAST Search History (Prior Art)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	12	((("5677604") or ("5023684") or ("6184679") or ("6636029") or ("6472878") or ("4283643") or ("6148784") or ("6429639") or ("6441604") or ("6459255") or ("6462531") or ("6683448"))).PN.	USPAT; USOCR	OR	OFF	2010/08/26 15:08
S2	37657	flux near5 (sens\$4 detect\$4 measur\$4)	US-PGPUB; USPAT	OR	ON	2010/08/26 15:09
S3	395393	current near5 (sens\$4 detect\$4 measur\$4)	US-PGPUB; USPAT	OR	ON	2010/08/26 15:10
S4	0	"10505321"	US-PGPUB; USPAT	OR	ON	2010/08/26 15:13
S5	11	"505321"	US-PGPUB; USPAT	OR	ON	2010/08/26 15:13
S6	949735	semiconductor	US-PGPUB; USPAT	OR	ON	2010/08/26 15:15
S7	2068551	controller (control\$4 near3 (unit system machine element))	US-PGPUB; USPAT	OR	ON	2010/08/26 15:17
S8	520871	conductor	US-PGPUB; USPAT	OR	ON	2010/08/26 15:18
S9	861	S2 and S3 and S6 and S7 and S8	US-PGPUB; USPAT	OR	ON	2010/08/26 15:19
S10	59	((KI NYA) near2 (NAKATSU)).INV.	US-PGPUB; USPAT	OR	ON	2010/08/26 16:09
S11	9	((KOI CHI) near2 (YAHATA)).INV.	US-PGPUB; USPAT	OR	ON	2010/08/26 16:09
S12	98	((MASATO) near2 (TAKAHASHI)).INV.	US-PGPUB; USPAT	OR	ON	2010/08/26 16:09
S13	2	((MITSUFUMI) near2 (IWANAKA)).INV.	US-PGPUB; USPAT	OR	ON	2010/08/26 16:10
S14	137	((RYUICHI) near2 (SAITO)).INV.	US-PGPUB; USPAT	OR	ON	2010/08/26 16:10
S15	10	((HARUKI) near2 (HAMADA)).INV.	US-PGPUB; USPAT	OR	ON	2010/08/26 16:11
S16	1772	257/734.ccls.	US-PGPUB; USPAT	OR	ON	2010/08/26 17:37

S17	404	318/400.37,400.38.ccls.	US-PGPUB; USPAT	OR	ON	2010/08/26 17:37
S18	9659	induction near2 current	US-PGPUB; USPAT	OR	ON	2010/08/26 17:39
S19	15645	(magnetic near2 flux) near5 (sens\$4 detect\$4 measur \$4)	US-PGPUB; USPAT	OR	ON	2010/08/26 17:40
S20	33	S6 and S7 and S8 and S18 and S19	US-PGPUB; USPAT	OR	ON	2010/08/26 17:40

EAST Search History (Interference)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	134784	current near3 (sens\$4 detect\$4 measur\$4)	US-PGPUB	OR	ON	2010/08/27 10:25
L2	3591	induction near2 current	US-PGPUB; UPAD	OR	ON	2010/08/27 10:26
L3	433220	semiconductor	US-PGPUB	OR	ON	2010/08/27 10:26
L4	5428	(magnetic near2 flux) near5 (sens\$4 detect\$4 measur\$4)	US-PGPUB	OR	ON	2010/08/27 10:30
L6	40	1 and 2 and 3 and 4	US-PGPUB	OR	ON	2010/08/27 10:38
L7	730	257/734.ccls.	US-PGPUB	OR	ON	2010/08/27 10:41

8/ 27/ 2010 10:41:59 AM

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